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AMENDMENTS TO THE ABSTRACT:

~~The present invention relates to~~ A silicon dual inertial sensor ~~sensors~~ made of a (110) silicon ~~chip~~. ~~The invention~~ chip comprises at least ~~[[an]]~~ a proof-mass, which is connected to ~~[[an]]~~ a corresponding inner frame with a plurality of sensing resilient beams to make it easier for ~~[[said]]~~ the proof-mass to move perpendicular to the surface of ~~[[said]]~~ the silicon chip (defined as z-axis), and each inner frame is connected to ~~[[the]]~~ an outer frame with a plurality of driving resilient beams, or connected to ~~[[the]]~~ common connection ~~beam~~ beams, which ~~[[is]]~~ are then connected to a central anchor with ~~[[the]]~~ common resilient supporting beams ~~beam~~ to make it easier for ~~[[said]]~~ the inner frame to move in parallel with the surface of ~~[[said]]~~ the silicon chip (defined as y-axis). Each inner frame is driven by a driver to move in an opposite direction along the y-axis, and also move the proof-mass in the opposite direction along the ~~y-axis~~, if y-axis. If there is a rotation rate input along the x-axis, it will generate ~~generates~~ a Coriolis force to make each ~~[[said]]~~ proof-mass ~~[[to]]~~ move in the opposite direction of the ~~z-axis~~, if z-axis. If an acceleration is input along the z-axis, the specific force will move the ~~[[said]]~~ proof-masses with the same ~~direction~~, when said proof-mass direction. When the proof-masses move or oscillate, the capacitance of the capacitor formed with sensing electrodes will change due to the change of distance; hence the of the distance. The moving distance can be obtained by measuring the change of capacitance; as the capacitance. Because the rotation rate outputs an alternating signal, and the acceleration outputs a direct signal, they can be separated with signal processing. ~~The present invention utilizes the deep vertical etching characteristics of the (110) silicon chip~~ is utilized to make the driving

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beam in order to control the driving resonance frequency more precisely, and improve
improves the yield rate and the performance of the gyroscope.